

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/500,224	MISAWA, TAKESHI	
Examiner	Art Unit	
Yogesh K. Aggarwal	2615	

	SEAD	CHED			
SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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interferen	search, see ce search printout	12/21/2005	YKA	

SEARCH NOT (INCLUDING SEARCH		
	DATE	EXMR
Searched 348/211.99,211.1,211.2,14.02,396/6	12/20/2005	YKA
Inventorship search conducted	12/21/2005	YKA
Ngoc-Yen vu	12/9/2005	YKA
David Ometz	12/9/2005	YKA
QEM		